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Atty Docket 0756-1998

Serial No. 09/352,194

## INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: July 13, 1999

Group Art Unit: 2823

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## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
HL	5,403,772	04/04/1995	Zhang et al.	438	166	
HL	5,426,064	06/20/1995	Zhang et al.	438	166	
HL	5,639,698	06/17/1997	Yamazaki et al.	438	486	
HL	5,843,833	12/01/1998	Ohtani et al.	438	486	
HL	5,879,977	03/09/1999	Zhang et al.	438	166	
HL	5,994,172	11/30/1999	Ohtani et al.	438	151	
HL	6,027,960	02/22/2000	Kusumoto et al.	438	166	
HL	6,054,739	04/25/2000	Yamazaki et al.	257	347	
HL	6,096,581	08/01/2000	Zhang et al.	438	149	
HL	6,124,154	09/26/2000	Miyasaka	438	151	
HL	6,140,165	10/31/2000	Zhang et al.	438	166	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
HL	Specifications and Drawings for Application Serial No. 09/369,158, "Semiconductor Device and Method of Manufacturing the Same", Filing Date: August 6, 1999, Inventors: Hisashi OHTANI et al.
HL	Specifications and Drawings for Application Serial No. 09/894,125, "Crystalline Semiconductor Thin Film, Method of Fabricating the Same, Semiconductor Device and Method of Fabricating the Same", Filing Date: June 29, 2001, Inventors: Shunpei YAMAZAKI et al.
HL	Specifications and Drawings for Application Serial No. 09/908,727, "Semiconductor Device and Method of Manufacturing the Same", Filing Date: July 20, 2001, Inventors: Hisashi OHTANI et al.

Examiner Fernando Toledo

Date Considered 10.11.2001

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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## INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

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## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
AK1	5,365,875	11/22/1994	Asai et al.	438	487	
AK1	5,846,869	12/08/1998	Hashimoto et al.	438	365	
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